

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	
Takayuki Ito) Group Art Unit: 2823
Application No.: 10/694,046) Examiner: TOBERGTE, Nicholas J.
Filed: October 28, 2003))
For: SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING THE SAME USING IMPLANTED ELECTRICALLY INACTIVE IMPURITIES (As Amended)) Confirmation No.: 7595)))

Mail Stop RCE

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

<u>AMENDMENT</u>

In reply to the Final Office Action mailed April 23, 2007, the period to reply to which extends thorough July 23, 2007, and in view of the attached Request for Continued Examination (RCE), Applicant respectfully requests reconsideration in view of the following remarks:

Amendments to the Claims are reflected in the listing of claims in this paper. Remarks/Arguments follow the amendment sections of this paper.

> 07/24/2007 JADDO1 00000096 060916 10694046 200.00 DA

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